

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT

APPLICANT(S): Tomoatsu Kinoshita DOCKET NO.: 09792909-5800
SERIAL NO.: 10/782,658 GROUP ART UNIT: 1765
DATE FILED: February 19, 2004 EXAMINER: Binh X. Tran
INVENTION: PROCESS FOR THE FABRICATION OF THIN-FILM DEVICE

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

S I R:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-SB08A form, in accordance with 37 C.F.R. §1.98, be made during the course of examination of the above-referenced application for United States Letters Patent. These references were cited in a Search Report issued January 23, 2006 in connection with Singapore Patent Application No. 200400848-8. Copies of the references and the search report are attached.

Respectfully submitted by,

Date: May 12, 2005 /David R. Metzger/ (Reg. 32,919)
David R. Metzger
SONNENSCHN NATH & ROSENTHAL LLP
P.O. Box 061080
Wacker Drive Station, Sears Tower
Chicago, IL 60606-1080
Telephone: 312/876-8000
Fax: 312/876-7934